

11th International Workshop on the Mechanisms of Vacuum Arcs
Granlibakken Resort,
Tahoe City, CA, USA
March 4, 2023



Relativistic 1D PIC-MCC modeling and simulation of impedance collapse in high-voltage diodes

Vedanth Sharma¹, Andres M. Castillo, Yusuke Yamashita,
Ken Hara

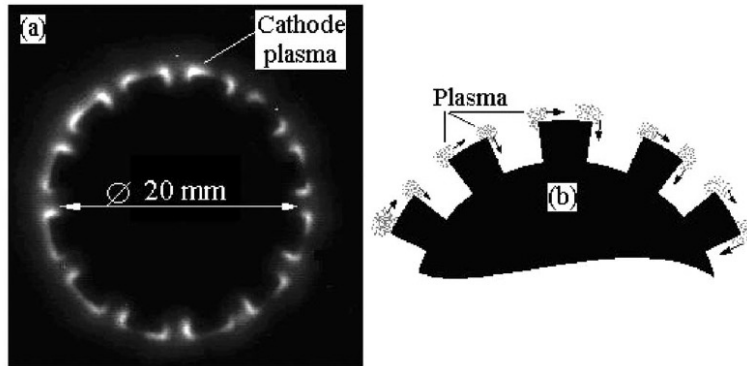
Plasma Dynamics Modeling Laboratory (PDML)

¹PhD Student, Aeronautics and Astronautics, Stanford University

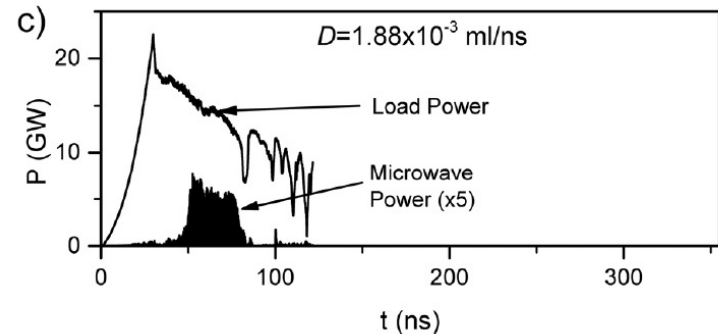
Acknowledgments: The work is supported by the Office of Naval Research under grant no. N00014-21-1-2698.
We thank the discussions with John Luginsland, Joe Schumer, Mike Cuneo, and Yakov Krasik.

Motivation: Plasmas in High Power Microwaves (HPMs)

- Plasma (ionized gas) forms in vacuum electron devices (VEDs) as the system becomes (i) smaller device or (ii) higher energy.
- Plasma formation and expansion in anode-cathode (AK) gap causes **impedance collapse** and **gap closure**, limiting the microwave pulse.



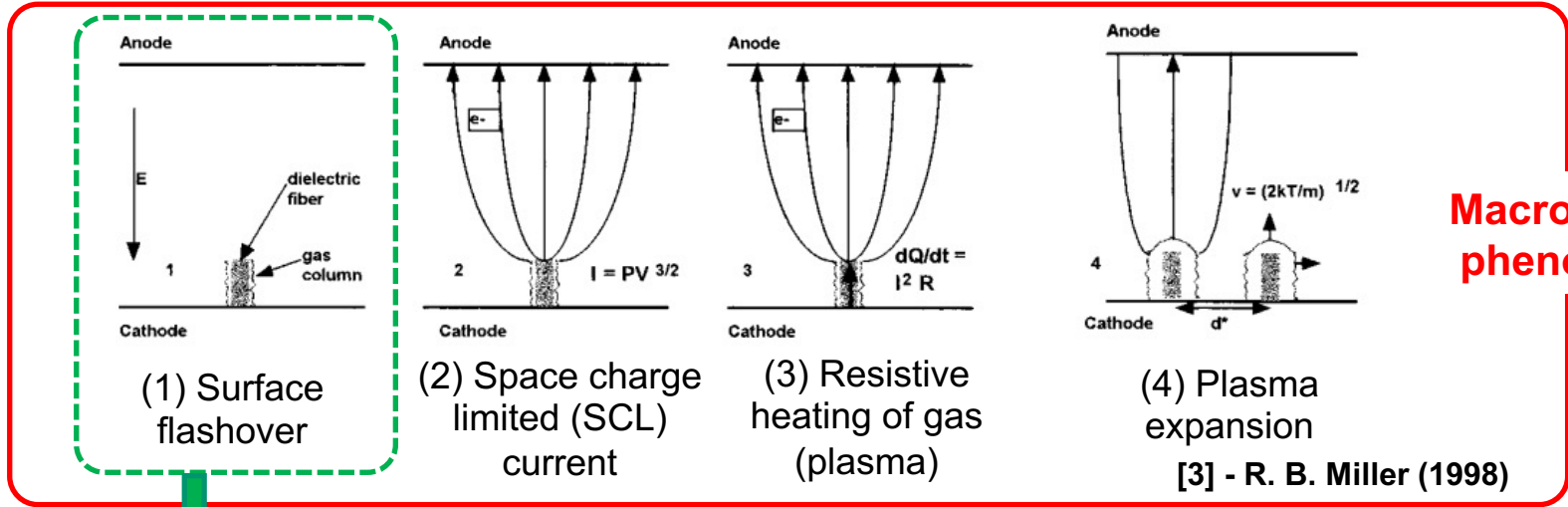
Cathode plasma formation in relativistic magnetrons (RMs) [Hadas et al. JAP 2008]



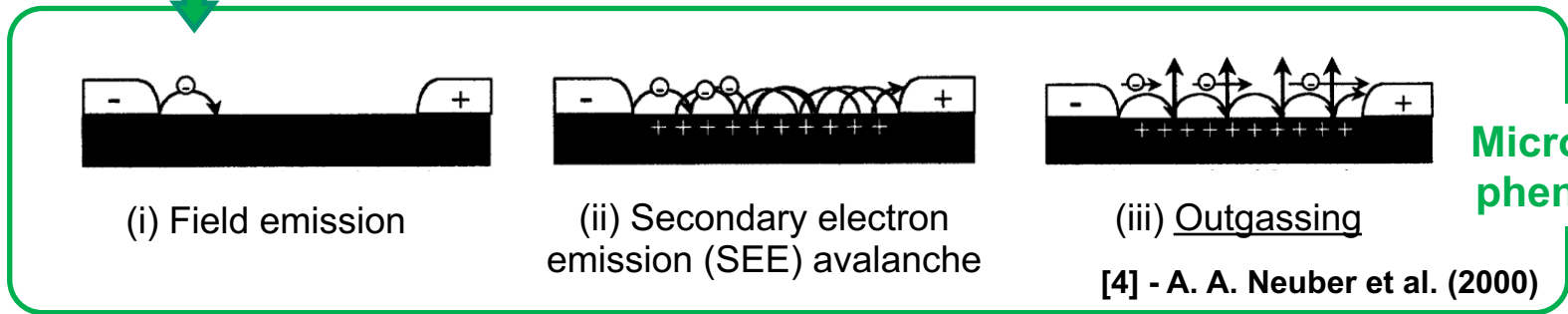
Microwave power cutoff due to cathode plasmas in magnetically insulated line oscillators (MILOs) [Rose et al. PoP 2013]



Physical Mechanisms of Plasma Formation in AK Gaps



Macroscopic phenomena



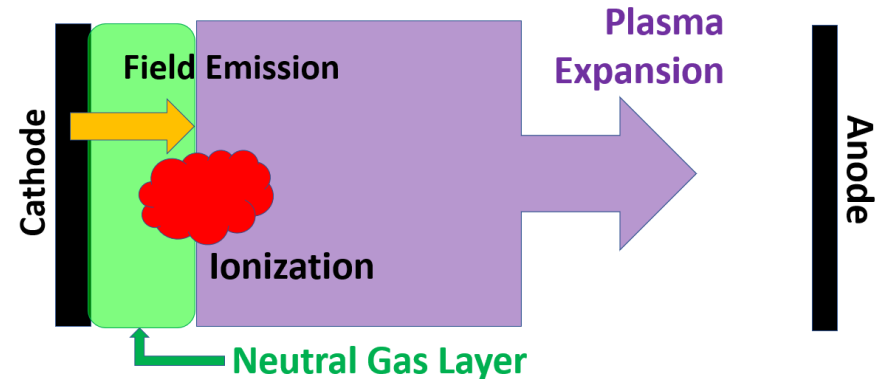
Microscopic phenomena



1D PIC-MCC Simulation Model

Goal: develop a self-consistent 1D particle-in-cell (PIC) Monte Carlo collision (MCC) model for plasma formation and expansion

- **AK gap** with a **neutral gas layer** (cf. **outgassing**) near the cathode
- High voltage results in **Fowler-Nordheim field emission** (FNFE) from cathode
- Emitted electrons **ionizes** the neutral layer forming the plasma near the cathode (self-consistent plasma formation; cf [1])
- Plasma **expands** towards the anode during a high-voltage pulse (~ 100 kV)
- Field enhancement factor ($\beta > 1$) is considered in FNFE model to account for micro-protrusions [2]



Plasma Formation & Expansion Processes



[1] D.R. Welch et al., Phys. Plasmas 16, 123102 (2009)
[2] G.A. Farrall et al., J. Appl. Phys. 46(2), 610-617 (1975)

Simulation: Input Parameters

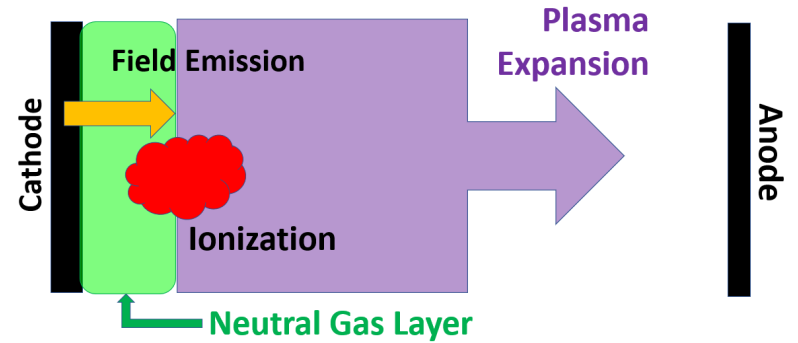
Baseline conditions

- Neutral layer: **atomic hydrogen**
- Neutral layer thickness = **100 μm**
- Neutral layer density = **$2.0 \times 10^{23} \text{ m}^{-3}$**
- Field enhancement parameter (**β**) = **500**

Sensitivity study

Collision model

- **Electron-neutral** ionization, excitation, and elastic: null-collision algorithm using Monte Carlo collision (MCC) [1]
- **Electron-electron** and **electron-ion** Coulomb collisions: Langevin method based on Fokker-Planck operator [2][3]



- AK gap = **1 cm**; Cells = **24000** ($dx = 0.417 \mu\text{m}$)
- $dt = 0.167 \text{ ps}$; Macroparticle weight = **2.0×10^{10}**



[1] Vahedi and Surendra, Comp. Phys. Comm. 87 (1-2), 179-198 (1995)

[2] M.E. Jones et al., J. Comp. Phys. 123 (1), 169-181 (1996)

[3] W.M. Manheimer et al., J. Comp. Phys. 138(2), 563-584 (1997)

Simulation Conditions

Grid convergence study (w/o Coulomb collisions):

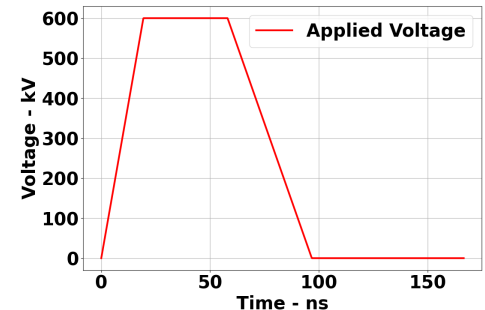
- up to **100,000** cells ($dx = 0.1 \mu\text{m}$) gave similar plasma expansion rates;
- computational time 7 days with 16 processors
- 24000 cells ($dx/\lambda_d \approx 1$); 100,000 cells ($dx/\lambda_d \ll 1$)

Neutral layer density and β were chosen based on sensitivity study

- Experimental literature suggests $\sim 10^{24} \text{ m}^{-3}$ neutral layer density near electrodes [1]
- β in the range of **100-600** has been reported in literature [2]

High-voltage pulse (based on experiments[3]): 100 ns pulse

- 40 ns flat-top at 600 kV
- 20 ns ramp-up; 40 ns ramp-down

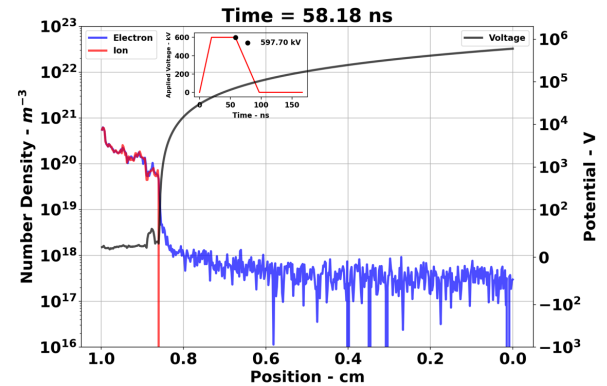
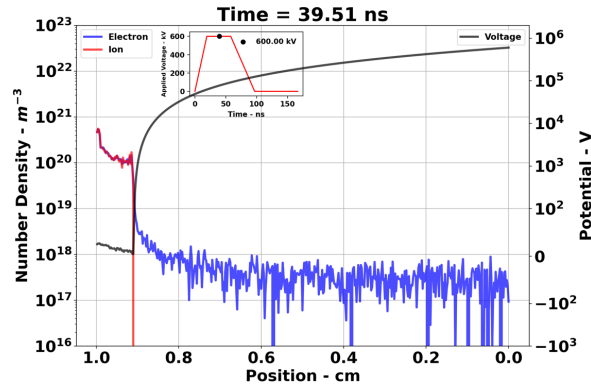
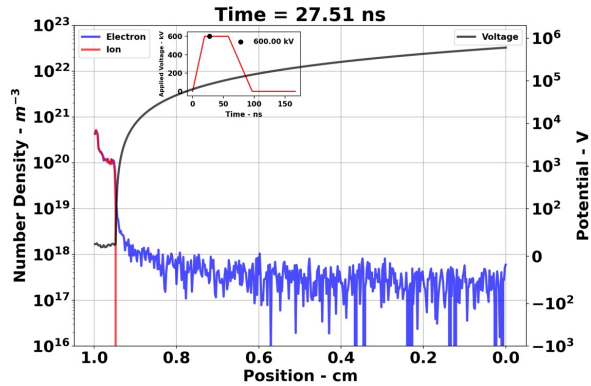
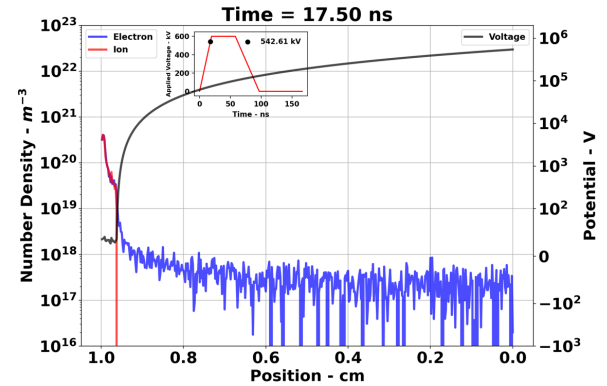
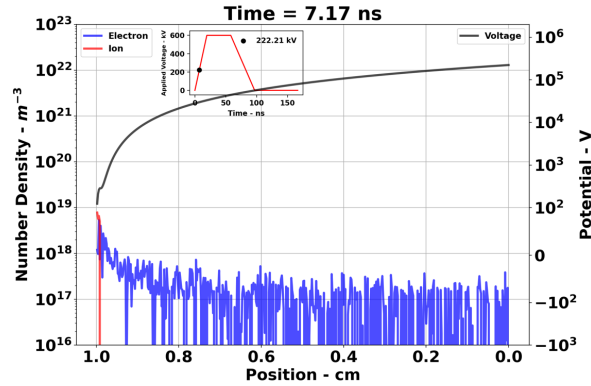
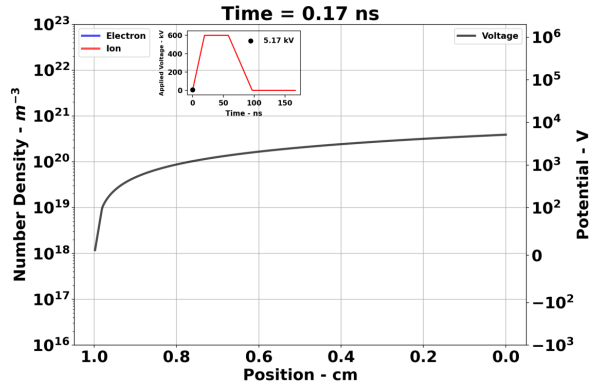


[1] R. B. Miller, J. Appl. Phys. 84, 3880–3889 (1998)

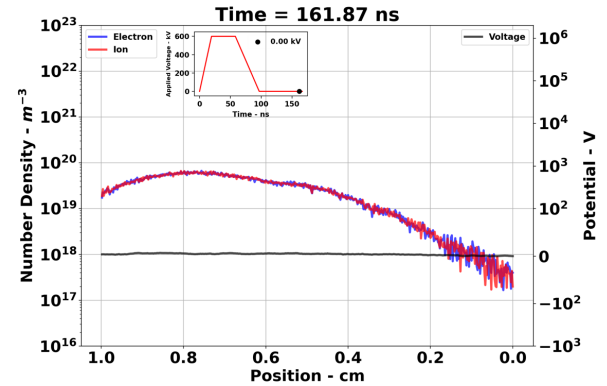
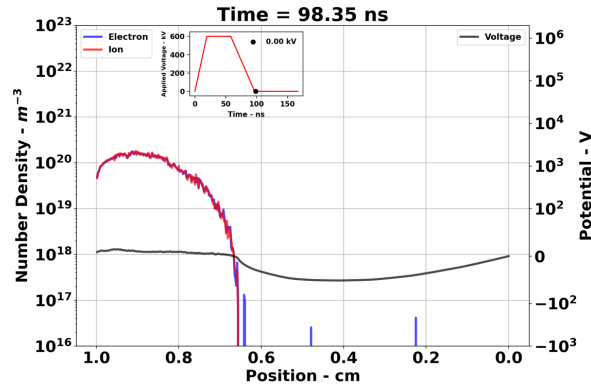
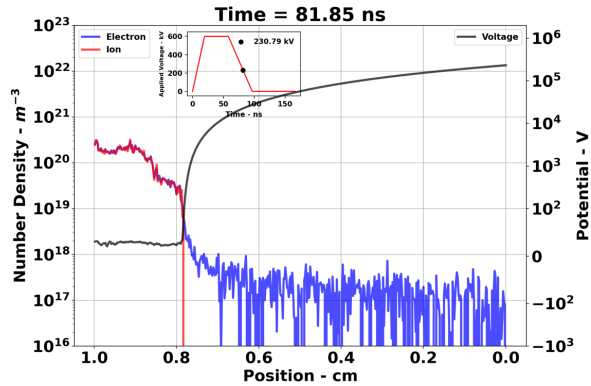
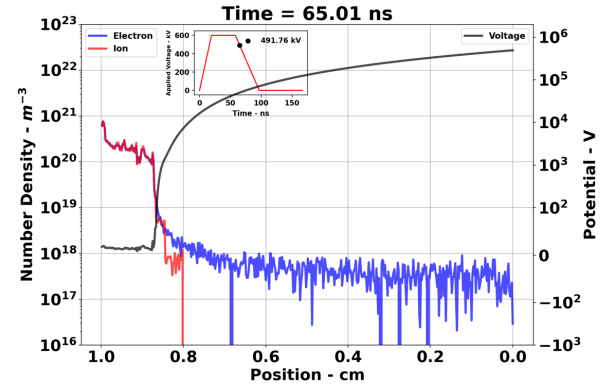
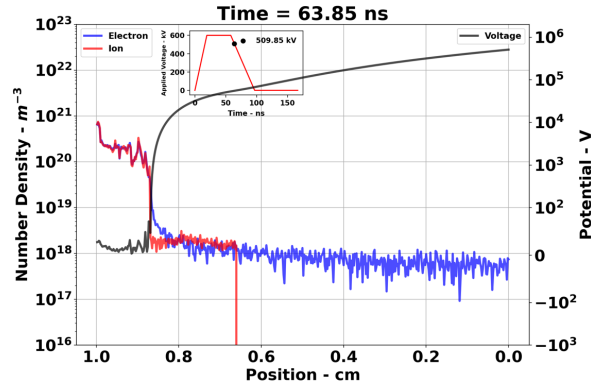
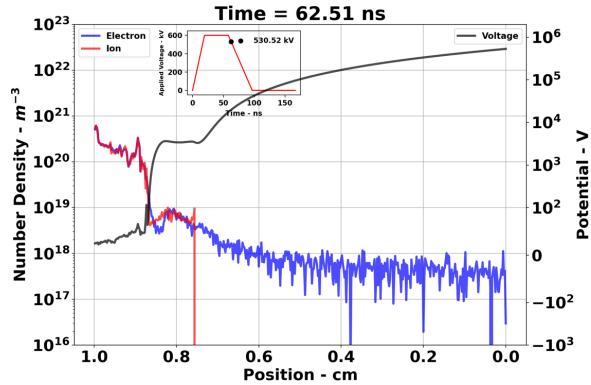
[2] S. Kobayashi et al., Appl. Surf. Science 146(1-4), 148-151 (1999); G.A. Farrall et al., J. Appl. Phys. 46(2), 610-617 (1975)

[3] R.K. Parker et al., J. Appl. Phys. 45(6), 2463-2479 (1974); D. D. Hinshelwood, IEEE Tran. on Plasma Science, 11(3), 188-196 (1983)

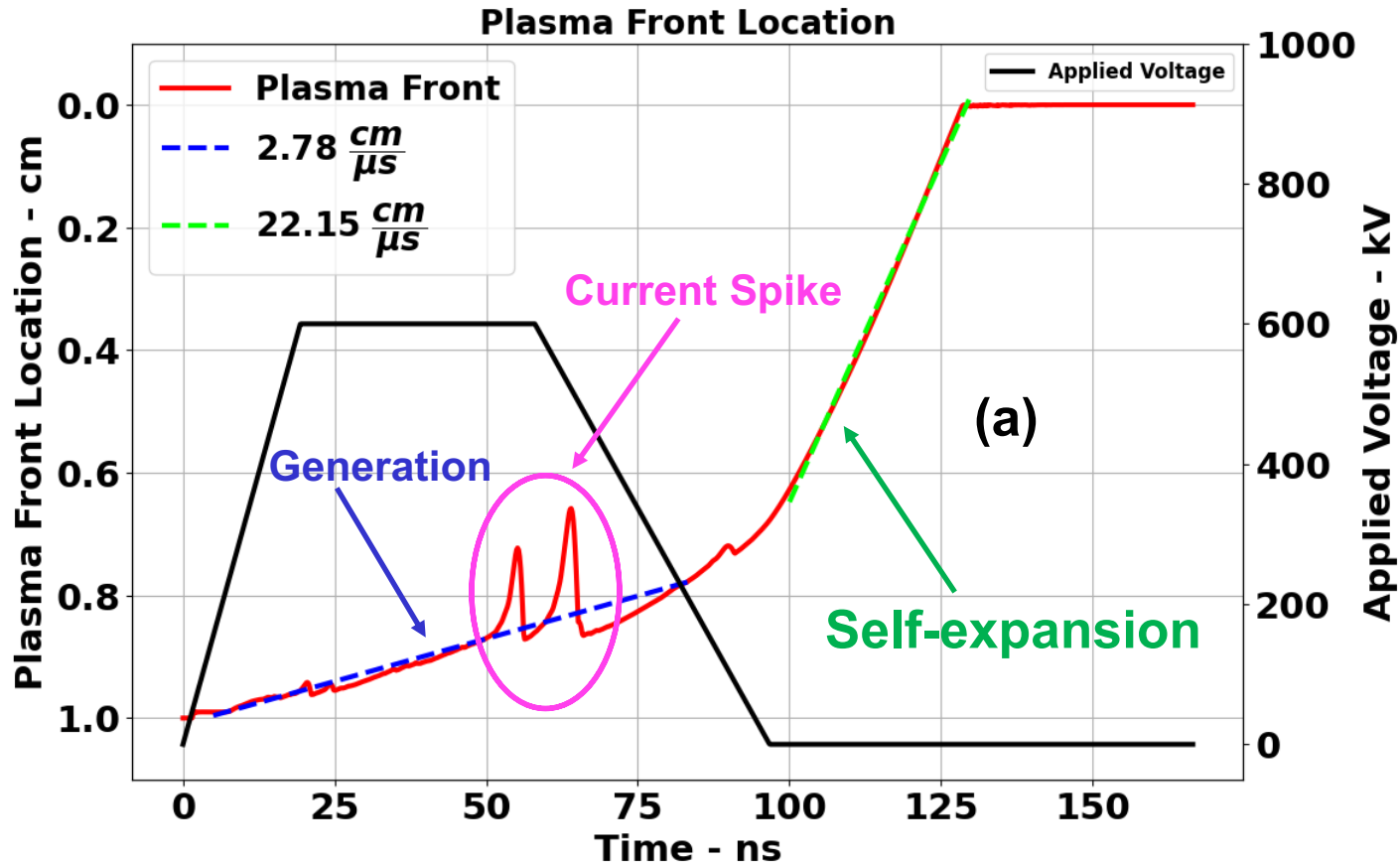
Result: Plasma Formation and Expansion



Result: Plasma Formation and Expansion



Result: Evolution of Plasma Front



Result: Evolution of Plasma Front

(a) Plasma expansion speed

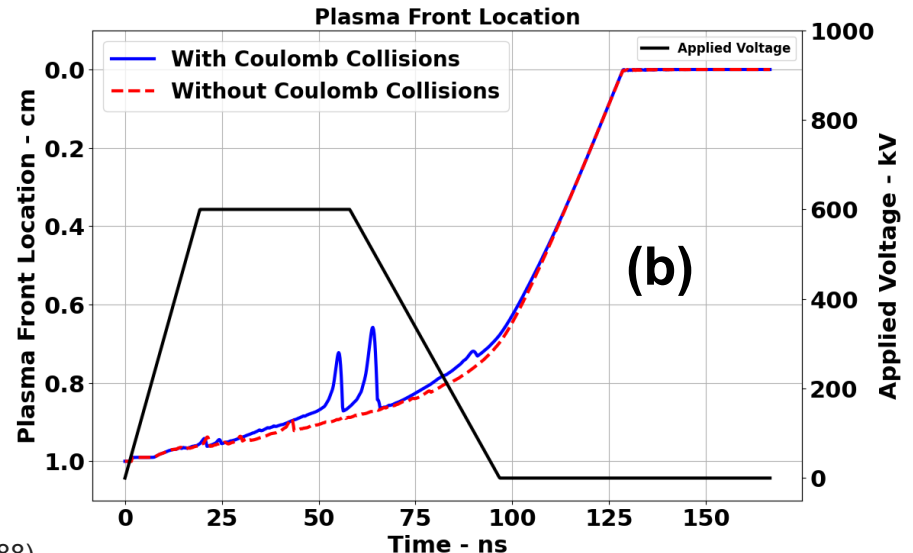
- Cf) Exp. measurement: **1-10 cm/ μ s** [1]
 1. During pulse, **generation speed (2.78 cm/ μ s)** agrees well with experimental results
 2. Towards the end of the pulse, **self-expansion speed (22.15 cm/ μ s)** due to diffusion

(b) Effect of Coulomb Collisions

1. Plasma expansion speed unchanged
2. Current instability observed

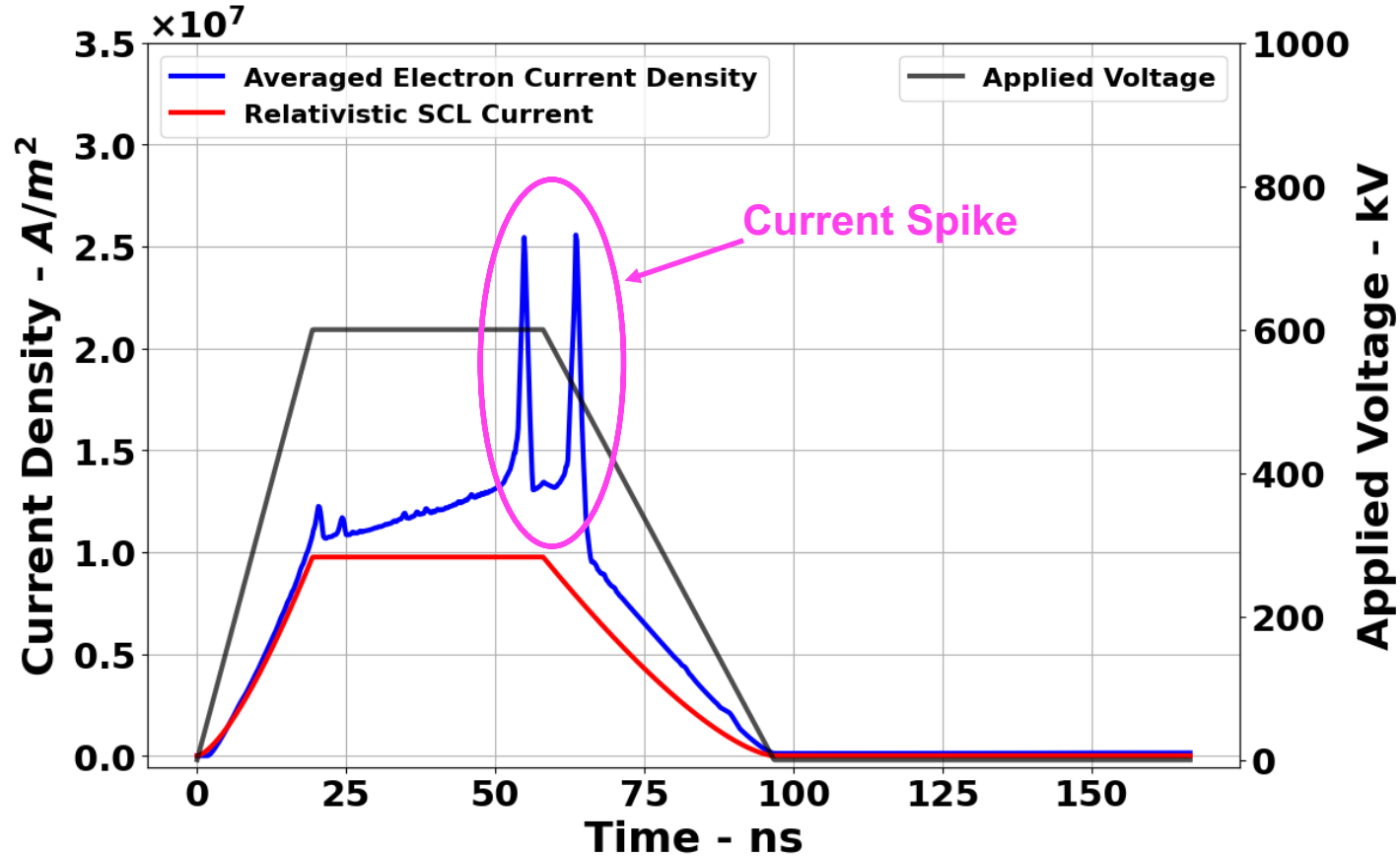


Coulomb collisions can be important for plasma expansion!



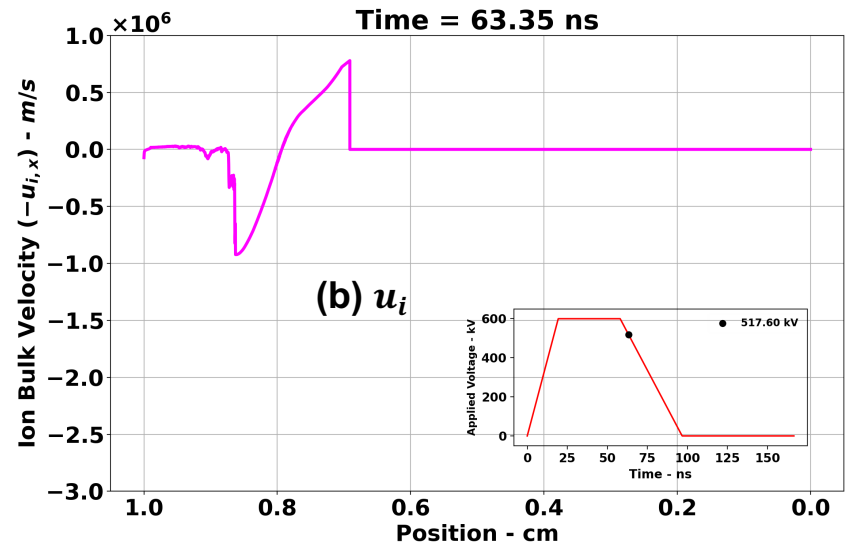
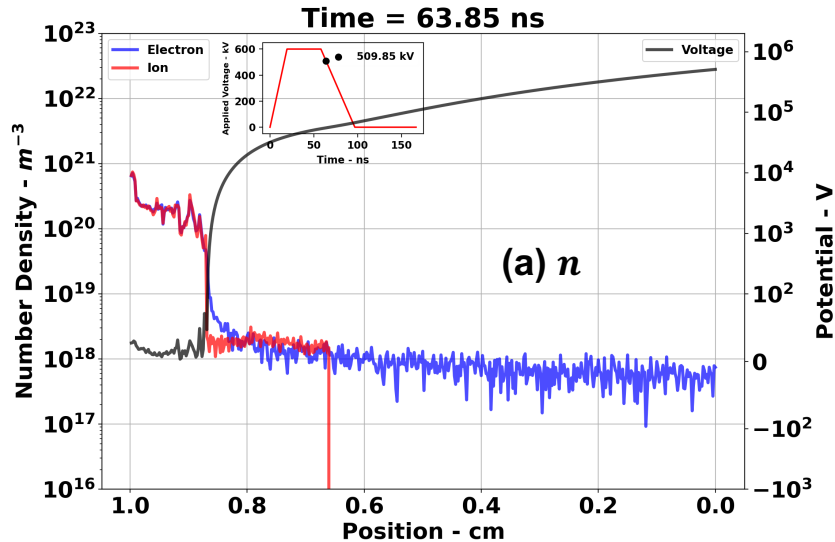
[1] R. E. Shefer et al., The Phys. of Fluids 31(4), 930-939 (1988)

Instability: Electron Current Density



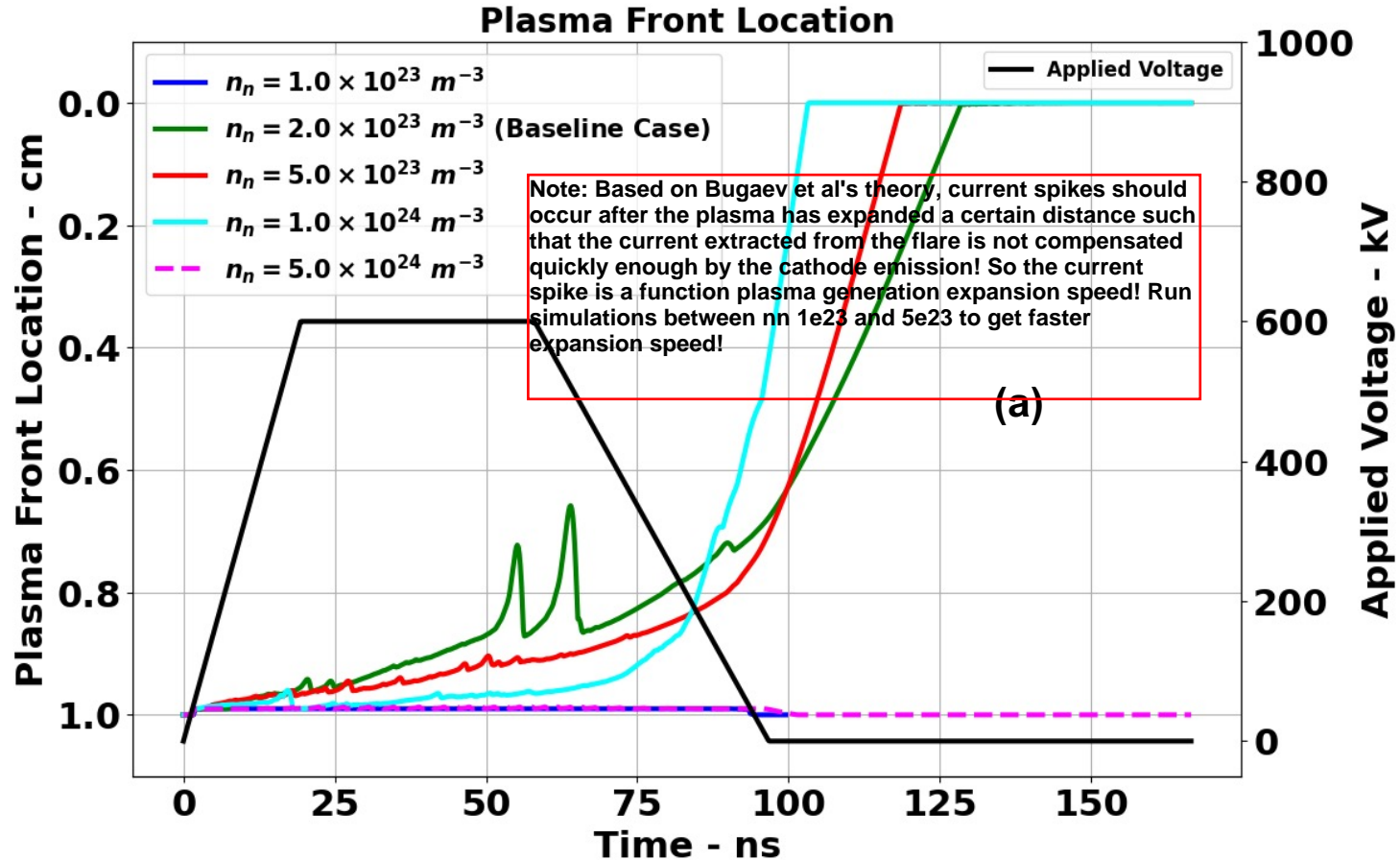
Instability: Electron Current Density

- We observe current spikes due to the acceleration of near-cathode plasma
- Experimental observation [1]: current instability can cause **x5 increase** in current density with a burst time of no more than **10 ns**

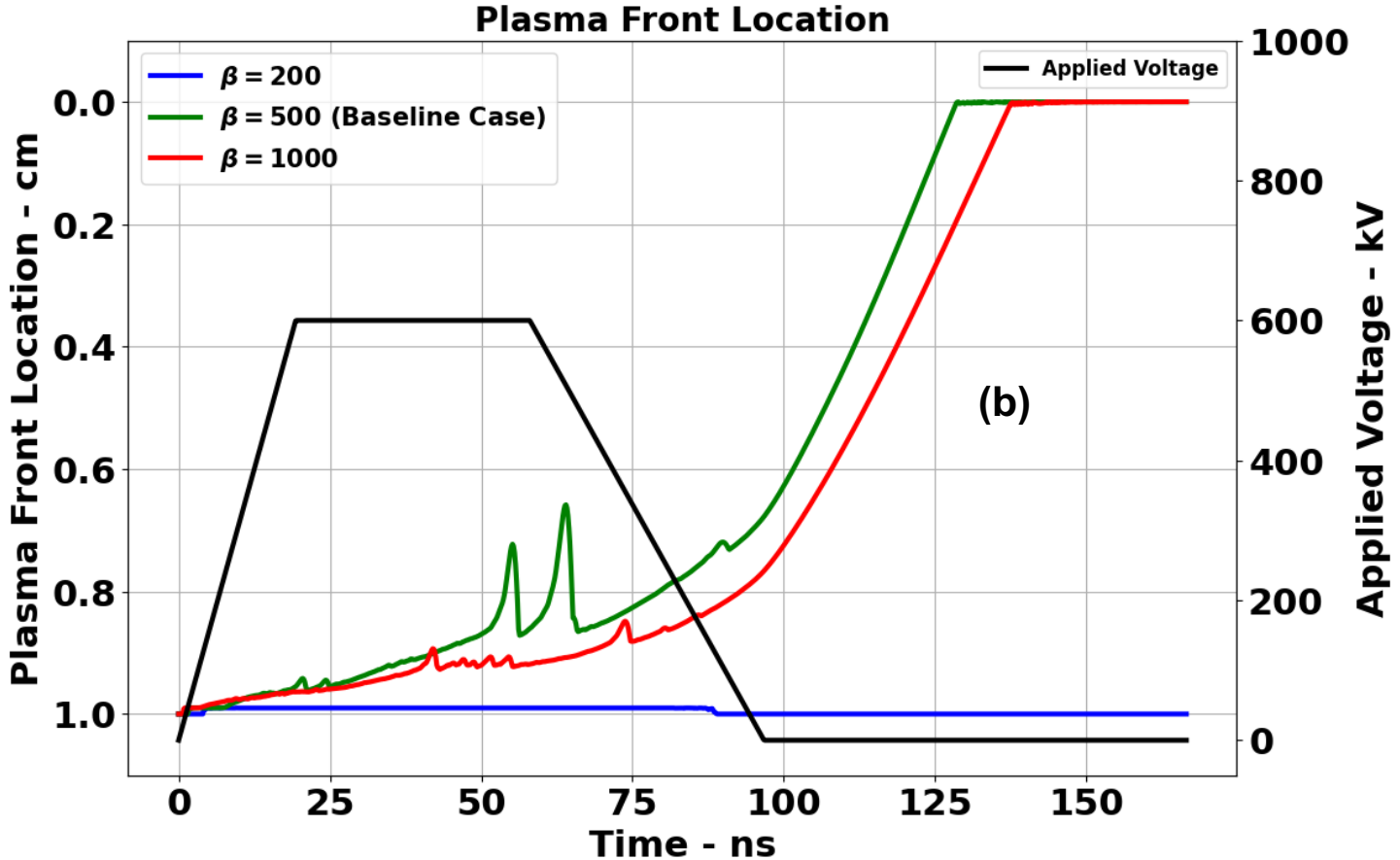


[1] S.P. Bugaev et al., Soviet Phys. Uspe. 18(1), 51 (1975)

Parameter Sensitivity: Neutral Layer Number Density



Parameter Sensitivity: Field Enhancement Factor



Result: Parameter Sensitivity Study

Effect of varying **field enhancement factor (β)** and **neutral layer density (n)** studied

1.) Cathode plasma layer expansion not observed

(a): for high ($n > 5 \times 10^{24} \text{ m}^{-3}$) & low ($n < 1 \times 10^{23} \text{ m}^{-3}$) neutral layer number density

(b): for low field-enhancement parameters ($\beta < 500$)

2.) Cathode plasma expansion speed sensitive to the neutral layer number density

- Generation phase: **1.5 - 2.78 cm/ μs**
- Self-expansion phase: **22.15 - 42.05 cm/ μs**



Summary

1D PIC-MCC model of plasma formation and expansion is developed.

- Simulation results of AK gap closure velocity in agreement with experiments: **1-10 cm/ μ s**
- Coulomb collisions are implemented using Langevin method (verified and tested)
- Coulomb collisions affect the plasma stability and can cause current spikes
- Current instabilities in simulation consistent with experimental observations in literature
- Plasma layer formation and expansion is a function of **neutral gas layer**, **β** (field emission enhancement factor), and **applied voltage**

Future work will take into consideration the effects of secondary electron emission, anode plasma formation, and the **surface flashover mechanism** (e.g., 2D simulations)

